

FORM PTO-1449

U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICEATTY. DOCKET NO.  
SAEG115.002APCAPPLICATION NO.  
10/502,511INFORMATION DISCLOSURE STATEMENT  
BY APPLICANTAPPLICANT  
NAKATSUKA, et al.FILING DATE  
July 23, 2004GROUP  
Unknown

(USE SEVERAL SHEETS IF NECESSARY)

## U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE (IF APPROPRIATE)

## FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
<i>MAT</i>	1.	JP 01-280465	11/10/89	Japan			Abstract	
<i>MAT</i>	2.	JP 09-241399	09/16/97	Japan			Abstract	
<i>MAT</i>	3.	JP 10-338615	12/22/98	Japan			Abstract	
<i>MAT</i>	4.	WO 98/55075	10/12/98	WIPO				
<i>MAT</i>	5.	WP 99/17303	09/30/97	WIPO				
<i>MAT</i>	6.	WO 01/45661 A2	12/11/00	WIPO				

EXAMINER  
INITIAL

## OTHER DOCUMENTS (INCLUDING AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.)

	7.	<u>Shin_ichiro Hiraide, "Research regarding the chemical reforming of the silk fibroin film," Research Report of Information Technology Research Institute of Nagano Prefecture, No. 17, p. 53-54 2001</u>						

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EXAMINER

*M. A. Treston*

DATE CONSIDERED

*2005 JUNE 30*

\*EXAMINER: INITIAL IF CITATION CONSIDERED, WHETHER OR NOT CITATION IS IN CONFORMANCE WITH MPEP 609; DRAW LINE THROUGH CITATION IF NOT IN CONFORMANCE AND NOT CONSIDERED, INCLUDE COPY OF THIS FORM WITH NEXT COMMUNICATION TO APPLICANT.